

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

Title of Invention	CONTINUOUS FLOW DEPOSITION SYSTEM						
Application Number:	10/604502						
Confirmation Number:	1501						
First Named Applicant:	Piero Sferlazzo						
Attorney Docket Number:	FLU-001						
Search string:	(4058430 or 6458416 or 6503330 or 20010007244 or 20020195056 or 20030023338 or 20030098372).pn.						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
✓	1	4058430	1977-11-15	Suntola, et al.		156	611
✓	2	6458416	2002-10-01	Derderian, et al.	B1	427	301
✓	3	6503330	2003-01-07	Sneh, et al.	B1	118	715
US Published Applications							
Note: Applicant is not required to submit a paper copy of cited US Published Applications							
init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
✓	1	20010007244	2001-07-12	Matsuse	A1	118	719
✓	2	20020195056	2002-12-26	Sandhu, et al.	A1	118	719
✓	3	20030023338	2003-01-30	Chin, et al	A1	700	121
✓	4	20030098372	2003-05-29	Kim	A1	239	548
Signature							
Examiner Name				Date			
KAPLA Mcke				11/15/04			



PTO/SB/08b (08-03)

Approved for use through 06/30/2006. OMB 0651-0031

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet

1

of

1

Complete If Known

Application Number	10/604,502
Filing Date	7/25/2003
First Named Inventor	SFERLAZZO
Art Unit	Not yet assigned
Examiner Name	Not yet assigned

Attorney Docket Number

FLU-001

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
KL	C1	MARTIN, High K Gate Dielectrics, LETI Annual Research Review- HighK Gate Dielectrics, June 15, 2001, Pgs. 1-16.	
↓	C2	NIINISTO, Oxide Thin Films By ALD For Advanced Applications, Helsinki University of Technology, Espoo, Finland, August 19th-24th 2002	
↓	C3	SUNTOLA, ET AL., Atomic Layer Epitaxy, Ann. Re. Mater. Sci., 1985, Pgs. 177-195, Annual Reviews Inc., Espoo, Finland.	

Examiner Signature

KAPLA Moore

Date Considered

11/15/04

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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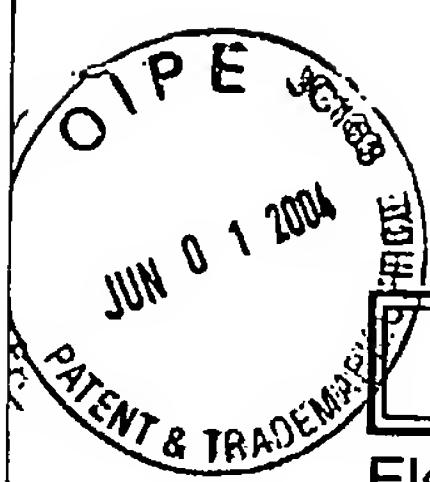
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Application Number:	10/604502							
Confirmation Number:	1501							
First Named Applicant:	Piero Sferlazzo							
Attorney Docket Number:	FLU-001PC							
Search string:	(6541353 or 6576062).pn.							
US Patent Documents								
Note: Applicant is not required to submit a paper copy of cited US Patent Documents								
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass	
W	1	6541353	2003-04-01	Sandhu, et al.	B1	438	478	
W	2	6576062	2003-06-10	Matsuse	B2	118	719	
Signature								
Examiner Name				Date				
KAPLA MOOPE				11/10/04				



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Confirmation Number:	1501						
First Named Applicant:	Piero Sferlazzo						
Attorney Docket Number:	FLU-001						
Search string:	(6319553).pn.						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
W	1	6319553	2001-11-20	McInerney, et al.	B1	427	250
Signature							
Examiner Name				Date			
KAPLA Moore				11/15/04			

